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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:

In Su Kim

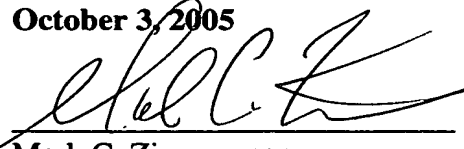
Serial No.: 10/758,188

For: Methods of Fabricating  
Semiconductor Devices

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Examiner: Bradley Smith

) I hereby certify that this paper is  
) being deposited with the United  
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) envelope addressed to: Mail Stop  
) Amendment, Commissioner for  
) Patents  
) P.O. Box 1450  
) Alexandria, VA 22313-1450, on  
) this date:  
) **October 3, 2005**  
)   
) **Mark C. Zimmerman**  
) **Registration No. 44,006**  
) **Attorney for Applicants**

**RESPONSE TO THE OFFICE ACTION DATED JULY 1, 2005**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated July 1, 2005, please enter the following amendments and consider the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 3 of this paper.

**Amendments to the Drawings** begin on page 5 of this paper.

**Remarks** begin on page 6 of this paper.

**An Appendix** including amended drawing figures is attached following page 7 of this paper.